

JUL 31 2003 4:13PM

KO & ANDROLIA

NO. 344

P. 1/9
HJ

PATENT
57A 3127
8/11/03
John

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

YOSHIKAZU NAKAYAMA et al.

Serial No.: 09/915,618

Filed: July 26, 2001

For: LITHOGRAPHIC METHOD USING
ULTRA-FINE PROBE NEEDLE

Art Unit: 2853

Examiner: Alfred E. Dudding

FAX RECEIVED

JUL 31 2003

TECHNOLOGY CENTER 2800

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action dated March 4, 2003, please amend the above-identified application as follows:

08/27/2003 AJOHNSD1 00000002 111445 09915618

01 FC:2251 55.00 DA

08/29/2003 AJOHNSD1 00000007 111445 09915618

01 FC:2252 150.00 DA